EFS-Web Receipt date: 02/29/2008

PTOSS058s (05.77)
Approved for use through 089/2007 M0854 (05.97)
U.S. Patent and Trademark Office U.S. DEPARTICENT OF COMMERCE
Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless in contains a valid OMB control uniform.

NFORMATION DISCLOSURE STATEMENT BY APPLICANT Not for submission under 37 CFR 1.99)	Application Number		10814697		
	Filing Date		2004-03-30		
	First Named Inventor Xiaolei		lei Shi et al.		
	Art Unit		1795		
	Examiner Name	Anna	L. Verderame		
	Attorney Docket Numb	er	140264-1		

U.S.PATENTS							Remove				
Examiner Initial*	Cite No	Patent Number	Kind Code <sup>1</sup>	Issue D	)ate	of cited Document			s,Columns,Lines where vant Passages or Relevan es Appear		
	1	6977137		2005-12	2-20	Borelli et al.					
If you wish to add additional U.S. Patent citation information please click the Add button.											
U.S.PATENT APPLICATION PUBLICATIONS Remove											
Examiner Initial*	Cite No	Publication Number	Kind Code <sup>1</sup>	Publica Date	ition	Name of Pate of cited Docu	Releva	ges,Columns,Lines where evant Passages or Relevant ures Appear			
	1										
If you wish to add additional U.S. Published Application citation information please click the Add button. Add											
				FOREIG	3N PAT	ENT DOCUM	ENTS		Remove		
Examiner Initial*	Cite No	Foreign Document Number <sup>3</sup>	Country Kind Code <sup>2</sup> j Code <sup>4</sup>		Publication Date	Name of Patentee or Applicant of cited Document		Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear		T5	
	1										
If you wish to add additional Foreign Patent Document citation information please click the Add button Add											
NON-PATENT LITERATURE DOCUMENTS Remove											
Examiner   Cite   Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.									T5		

"" O W. I. D	10011007	ALL 170			
FS-Web Receipt date: 02/29/200	Application Number		10814697	10814697 -	GAU: 1/95
	Filing Date		2004-03-30		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	First Named Inventor	Xiaole	ılei Shi et al.		
	Art Unit		1795		
	Examiner Name	Anna	L. Verderame		
	Attorney Docket Numb	er	140264-1		

	T. D. Krauss et al., "Femtosecond measurement of nonlinear absorption and refraction in CdS, ZnSe, and ZnS," American Institute of Physics, Volume 65, No. 14, October 3, 1994.							
If you wish to add additional non-patent literature document citation information please click the Add button Add								
EXAMINER SIGNATURE								
Examiner Signature /Anna Verderame/		Date Considered	03/03/2008					
*EVAMINED: Initial if reference considered subother or not sitation is in conformance with MPED 600. Draw line through a								

¹See Kind Codes of USPTO Patent Documents at <a href="https://www.USPTO.GOV">www.USPTO.GOV</a> or MPEP 901.04. <sup>2</sup> Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>3</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precode the serial number of the patent document. <sup>4</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>5</sup> Applicant is to place a check mark here if English language translation is attached.

citation if not in conformance and not considered. Include copy of this form with next communication to applicant.